

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

AMENDMENT		
		adile M. Stampes
FABRICATION METHOD THEREOF	)	Alexandria, VA 22313-1450, on <u>3.17.05</u> .
For: SEMICONDUCTOR DEVICE AND	)	being deposited with the United States Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450,
Filed: June 17, 1999	)	
Serial No. 09/334,646	)	CERTIFICATE OF MAILING I hereby certify that this correspondence is
Shunpei YAMAZAKI et al.	)	Examiner: S. Hu
In re Patent Application of:	)	Group Art Unit: 2811

Honorable Commissioner of Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

In response to the Official Action dated November 18, 2004, please consider the following amendments and remarks in connection with the above-identified application.

Amendments to the Specification begin on page 2 of this paper.

Amendments to the Claims are reflected in the listing of claims which begins on page 3 of this paper.

Amendments to the Drawings begin on page 14 of this paper and include an attached replacement sheet.

Remarks begin on page 15 of this paper.